

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

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APPL NUM 10083756	FILING DATE 02/25/2002	CLASS 257	SUBCLASS	GAU 2811	EXAMINER Q. Vu
**APPLICANT'S: Kim Do-Hyung; Kim Sung-Eui;					
**CONTINUING DATA VERIFIED: ST AVAILABLE COPY					
** FOREIGN APPLICATIONS VERIFIED: REPUBLIC OF KOREA 2001-09382 02/23/2001					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>			
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 4591-227	
TITLE : Method for forming layer for trench isolation structure U.S DEPT. OF COMM./PAT.& TM-PTO-436L(Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.	Print Fig.
TERMINAL		Primary Examiner		
DISCLAIMER		Application Examiner		
PREPARED FOR ISSUE				
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